

12/2/02 #8  
**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kazuyoshi TAMURA et al.

Group Art Unit: 1765

Application No.: 09/696,955

Examiner: M. A. Anderson

Filed: October 27, 2000

Docket No.: 107703

For: SILICON FOCUS RING AND METHOD FOR PRODUCING THE SAME

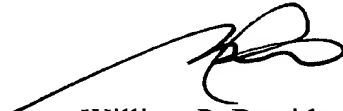
**LETTER TO THE OFFICIAL DRAFTSPERSON**

Director of the U.S. Patent and Trademark Office  
Washington, D.C. 20231

Sir:

Please substitute the attached 1 sheet of formal drawings depicting Figures 1A, 1B and 2 for the corresponding drawings filed with the application. The attached drawings have been corrected pursuant to the Notice of Draftspersons Patent Drawing Review attached to Paper No. 2.

Respectfully submitted,



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WPB:GWT/lrd

Date: December 2, 2002

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